



AF/2824
IFW

Docket No.: 8733.517.00-US
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Seung-Kyu Choi et al.

Confirmation No.: 2898

Application No.: 10/028,304

Art Unit: 2826

Filed: December 28, 2001

Examiner: J. P. Mondt

For: THIN FILM TRANSISTOR SUBSTRATE AND
FABRICATING METHOD THEREOF

Customer No.: 30827

AMENDMENT AFTER FINAL ACTION (37 C.F.R. SECTION 1.116)

MS AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

INTRODUCTORY COMMENTS

In response to the Office Action dated June 16, 2004 (Paper No. 06122004), please amend the above-identified U.S. patent application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 10 of this paper.